

AF / 7-65
#

TC 1700

EXAMINING GROUP 1765

0630-1187P



Applicant:	Tae-Woong KANG	Conf.:	9755
Appl. No.:	09/942,784	Group:	1765
Filed:	August 31, 2001	Examiner:	Kin Chan CHEN
For:	METHOD FOR FORMING CAPACITOR OF SEMICONDUCTOR DEVICE		

LARGE ENTITY TRANSMITTAL FORM
FOR REPLY AFTER FINAL UNDER 37 C.F.R. § 1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 15, 2003

Sir:

Transmitted herewith is an amendment in the above-identified application.

- ☐ The enclosed document is being transmitted via the Certificate of Mailing provisions of 37 C.F.R. § 1.8.
- ☐ The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	18	-	20	=	0	\$ 18	\$0.00
INDEPENDENT	2	-	3	=	0	\$ 86	\$0.00
<input type="checkbox"/> FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM						\$290	\$0.00
						TOTAL	\$0.00

- ☒ Petition for one (1) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). \$110.00 for the extension of time.
- ☐ No fee is required.
- ☒ Check(s) in the amount of \$110.00 is(are) enclosed.
- ☐ Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.


If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. §§1.16 or 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By 

Joseph A. Kolasch, #22,463


JAK/REG:jls
0630-1187P

P.O. Box 747
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Attachment(s)

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OCT 20 2003

TC 1700



MS AF
REPLY UNDER
37 C.F.R. § 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1765

PATENT
0630-1187P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Tae-Woong KANG	Conf.:	9755
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AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 15, 2003

Sir:

In reply to the Office Action dated June 23, 2003, the period for response having been extended one (1) month to October 23, 2003, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes a Claim Set As Amended and Remarks.

10/16/2003 HVUONG1 00000042 09942784

01 FC:1251

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